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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known				
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First Named Inventor	George L. Bees			
Group Art Unit	2828			
Examiner Name	Inzirillo, Gioacchino			
Attorney Docket Number	FOM-119.01			

U.S. PATENT DOCUMENTS						
Examiner Cite Initials No.1	U.S. Patent Docume	Name of Patentee or	Applicant Date of Publication	of Pages, Columns, Lines, Where Relevant		
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7N	7N AB US 5164892A1		Kimbara	11/17/92	*see attached search report*	
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Cite No.1	For	eign Patent Doc		i			
	Office ³		Kind Code ⁵ (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Тв
AA	DE	DE 3500182 A1		SP K Bjuro Akademii Nauk Eston	7/10/86	*see attached search report*	
AC	PCT	99/317 73A		Cymer, Inc.	6/24/99	*see attached search report*	
AD	PCT	WO 00/046 12A		Cymer, Inc.	1/27/00	*see attached report*	
AE	DE	DE 4100719 A1		LAR - Laser and Analytical Research	7/16/92	*see attached report*	
	AC AD	AA DE AC PCT AD PCT	AA DE 3500182 A1 WO AC PCT 99/317 73A WO AD PCT 00/046 12A DE 4100719	AA DE 3500182 A1 AC PCT 99/317 73A WO AD PCT 00/046 12A DE AE DE 4100719	AA DE 3500182 SP K Bjuro Akademii Nauk Eston AC PCT 99/317 Cymer, Inc. AD PCT 00/046 Cymer, Inc. DE LAR - Laser and Analytical	AA DE 3500182 Akademii Nauk Eston 7/10/86 AC PCT 99/317 Cymer, Inc. 6/24/99 AD PCT 00/046 Cymer, Inc. 1/27/00 AE DE 4100719 LAR - Laser and Analytical 7/16/92	AA DE 3500182

Examiner Signature	Tuan	Muyan	Date Considered	11-6-02
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the